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Introduction

 $MoS₂$ is an example of a transition metal dichalcogenide that possesses an indirect bandgap with a transition from indirect to direct band gap when transitioning from bulk to few or monolayer thickness experimentally and through computer simulations.^{1–4} The structure of MoS₂ allows fabricating monolayers through exfoliation¹ or growth on substrates.⁵⁻⁷ The charges on the surface and in the bulk of $MoS₂$ are almost identical which is related to the van der Waals type bonding between layers.⁸ The electronic and optical properties of $MoS₂$ are changing with the number of monolayers⁹⁻¹² and at the edges of the crystallites.¹³ Changing the numbers of monolayers forming a sample allows for tuning its properties – also through combining with other metal dichalcogenides $9 -$ for a range of applications such as energy conversion and storage¹⁴ and biomedical applications.¹⁵ A challenge in using monolayer $MoS₂$ is fabricating the material as large scale crystallites.¹⁶ Several calculations of the band structure of monolayer $MoS₂$ have been conducted. $17-21$ Reducing the thickness of the material from bulk to a monolayer also increases the bandgap overall.²² An increase of the band gap of $MoS₂$ from 1.29 eV to 1.9 eV was found by Mak et $al¹$ It has been reported that with a fine control over the number of layers forming a $MoS₂$, the work function of a surface may be tuned allowing for surfaces to be tuned for specific interfacing and the surface potential can be changed.23 The electronic properties such as the band structure and exciton binding energies and the geometric properties of a **PAPER**
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The valence electron structure of exfoliated monolayer MoS₂ deposited onto $SiO₂$ was determined by UV photoelectron spectroscopy through component analysis in combination with Auger electron microscopy. The valence electron cut-off for bulk MoS₂ was found at 0.64 eV binding energy whilst monolayer MoS₂ and few layer MoS₂ have higher binding energies of 0.89 eV and 1.26 eV respectively. SiO₂ is known to interact only weakly with MoS₂. Thus, the valence electron structure of higher binding energy determined here is thus considered to represent that of a material not affected by strain. The implications of the change in the valence electron cut-off are discussed.

> $MoS₂$ sample change when strain is introduced into a sample.^{17,24,25} The properties of $MoS₂$ can also be changed through doping.19

> Direct measurements of the band structure of MoS₂ are rare and difficult to perform. The reason is that photoelectron spectroscopy, as the method typically used for investigating the electronic structure of surfaces, probes several monolayers at a sample surface and in case of monolayer $MoS₂$ therefore the monolayer plus the top few layers of the substrate. The resulting spectra thus show the density of states (DOS) of the monolayer M_0S_2 plus that of the substrate.^{25–28} One of the few examples of measuring the DOS of monolayer $MoS₂$ are from Eknapakul et al. who determined the band structure of monolayer $MoS₂$ with intercalated potassium layers with angle resolved photoelectron spectroscopy (ARPES).⁵ However, due to the presence of the K interlayers the results found through this work have to be considered to differ from monolayer $MoS₂$. This situation leaves the literature of investigating $MoS₂$ monolayers deposited onto substrates with a situation that the electron spectrum of $MoS₂$ is known with a high degree of plausibility but not with spectra of $MoS₂$ only.

> It is an intrinsic problem of all methods of photoelectron spectroscopy that in the of investigating monolayer materials deposited onto a substrate, that the contribution of the monolayer and the substrate cannot be separated unless the spectrum of the substrate covers an entirely different electron binding energy range compared to the monolayer material. The latter is usually not the case. This problem could only be overcome by applying an electron spectroscopy method which is sensitive to the outermost layer only such as metastable induced electron spectroscopy (MIES) or by applying a procedure in the data evaluation which allows to separate the contributions of the monolayer and the substrate. The disadvantage of MIES is that it would be sensitive only to the outer electronic structure of the monolayer and not to the overall monolayer. We thus have

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Electronic structure of thin $MoS₂$ filmst

chosen in the present work a different route and applied a component analysis method for the data evaluation. The variation of the surface coverage with $MoS₂$ can be used as advantage in a component analysis because it introduces a variation in the contribution of the substrate and the monolayer to the spectra taken from various spots of the sample and allows for a mathematical separation of the spectral contributions of monolayer and substrate. The method developed in this work can in general be used for investigating any monolayer material deposited onto a substrate.

The aim of the present work is to determine experimentally the valence electron structure of monolayer $MoS₂$. UV photoelectron spectroscopy (UPS) is applied, and the data are processed through component analysis separating the spectral contributions of the monolayer $MoS₂$ and that of the substrate. The data processing also allows to separate the spectra of monolayer and few layer $MoS₂$ showing the transition of the valence electron structure from the monolayer over the few layer to bulk MoS₂. We have chosen a Si wafer with naturally oxidised $SiO₂$ as substrate. $SiO₂$ is known to interact only weakly with the $MoS₂$ monolayer²⁹ which we assume is holding also in the present case. In this way the valence electron structure of monolayer $MoS₂$ can be determined where the valence electron structure is only weakly modified through the interaction with the substrate. The combination of careful preparation of a sample containing mainly monolayer $MoS₂$ and some few layer $MoS₂$ with the component analysis of the electron spectra allows to show experimentally the change of the valence band edge with the thickness of $MoS₂$. RSC Applied interfaces one control of the simple article is the model of the simple are published on 2023. The model of the simple are published on 2022. The model of the simple are the model of the simple are the simple

Experimental

Materials and sample preparation

Materials. Monolayer MoS₂ crystals are grown on Si substrates with 300 nm thermal oxide using chemical vapor deposition (CVD) process according the method described by George et al.⁷ The grown $MoS₂$ crystals were transferred onto Si (100) substrate from MTI corporation (B doped with a resistivity of 0.001–0.005 ohm cm) with native oxide using PMMA assisted transfer protocol.⁶ For comparison a bulk $MoS₂$ sample from 2D Semiconductors (BLK-MOS2-SYN) was also investigated.

X-ray photoelectron spectroscopy and ultraviolet photo electron spectroscopy

The $MoS₂$ samples were investigated using XPS and UPS in an ultra-high vacuum (UHV) system built by SPECS (Berlin, Germany) which has a base pressure of a few 10^{-10} mbar. The He* and UV light (He I line) were generated in a two stage cold cathode gas discharge from MFM Analytical Systems (Claustal-Zellerfeld, Germany). A non-monochromatic X-ray source is used to generate Mg Kα radiation. For detecting the emitted electrons a hemispherical Phoibos 100 energy analyser from SPECS (Berlin, Germany) was used. UPS and XPS were recorded at a pass energy of 10 eV and a bias of −10 V was applied to the samples for the UPS and metastable induced electron spectroscopy (MIES) measurements. The angle of UV and X-ray source radiation and the analyser are both 54° with respect to the surface normal of the sample. High resolution XP spectra were fitted with combined Gaussian–Lorentzian components and a correction for the Shirley background.³⁰ For quantification of relative intensities the cross sections calculated by Yeh have been used.³¹

For UPS the samples were irradiated with UV photons from the HeI line ($hv = 21.2$ eV). The photons excite the valence electrons through the photoelectric effect. For HeI UPS the surface sensitivity is limited by the electron mean free path to the upper $2-3$ nm of the sample.³² The binding energy of the electrons in the sample is determined by eqn (1).

$$
E_{\text{binding}} = 21.2 \text{ eV} - E_{\text{kinetic}} - \Phi_{\text{spec}} \tag{1}
$$

where E_{binding} is the binding energy of the electrons in the sample, E_{kinetic} is the kinetic energy of the emitted electrons and Φ_{spec} is the work function of the spectrometer. For XPS the binding energy is calculated in a similar way. The probing depth of XPS at this energy is about 6–7 nm, and slightly higher than in case of UPS due to the higher kinetic energy of the emitted electrons.³²

MIES was applied at the same time as UPS. The MIE spectra have no significant features in the region up to 6 eV. The reason in the present case is that $MoS₂$ has states at low binding energy which favours the resonance ionisation (RI) followed by Auger neutralisation (AN) mechanism for the deexcitation of the metastable He atoms.³³

While running UPS and MIES, the measurements were monitored for evidence of charging. As a routine, the measurements are conducted in a sequence of acquiring three spectra consecutively with the first two spectra consisting of single scans only. The samples are started to be exposed to UV photons and He* just before the data acquisition is started. This is facilitated by keeping the valve between the UV and He* source and the analysis chamber of the equipment closed until the data acquisition starts. In case the secondary onset of the measurements stays stable without showing a shift between the three measurements, charging of the sample during the measurements can reasonably be excluded. We also did not find charging of the MoS2 during the XPS measurement.

Scanning electron microscopy and auger electron spectroscopy

The $MoS₂$ on $SiO₂$ samples were analysed with a PHI710 Scanning Auger Nanoprobe (Flinders Microscopy and Microanalysis, Flinders University) with an electron energy of 1 keV. Auger electron spectroscopy (AES) is a similar spectroscopic technique to XPS. The sample is irradiated with an electron beam with a kinetic energy of the electrons from 1 to 25 keV which results in the excitation of electrons in the sample

leading to their emission. In the present work 10 keV electrons were used. The atom from which an electron is emitted is in an excited state which subsequently transits to the ground state leading to the emission of an Auger electron with an energy characteristic for the specific element. The emission of the electrons is detected with a detector with spatial resolution similar to that of the scanning electron microscope (SEM) allowing spatially resolved elemental mapping of the surface. AES and AEM can be combined in one instrument which is called Auger electron microscopy (AEM). AEM has an advantage over SEM in conjunction with energy-dispersive X-ray spectroscopy (EDX) due to the surface sensitivity of AEM.

Heating procedure

Before applying electron spectroscopy, the samples were heated to 723 K.

Measurement procedure

XPS and UPS were measured on nine different locations using a medium magnification lens mode with a diameter of the spot size for the analysis of 1.4 mm. This allows for applying a component analysis to separate the components in UPS the spectra related to the various thickness of $MoS₂$ and the substrate. The central spot is located approximately in the middle of the $MoS₂$ shown in Fig. S1.† The other nine spots are located +2 mm or −2 mm to the left and right and top and bottom of the central spot. As an example, the spot $(x, z) +2/2$ is located 2 mm above and 2 mm to the left of the central spot.

SVD analysis

A mathematical algorithm known as singular value decomposition (SVD) is used to analyse a series of UP spectra. The details of the procedure can be found in literature. $34-36$ A summary is provided in the ESI.† The SVD procedure results in reference spectra which are used to reproduce the measured UP spectra as linear combination. The reference spectra represent spectra of a surface with a specific composition and electronic structure.

Raman spectroscopy

Raman spectra were acquired using a WITec alpha 300 R Raman microscope at an excitation laser wavelength of 532 nm $(\leq 5$ mW) with a ×40 objective (numerical aperture 0.60). A minimum of 15 Raman spectra were recorded per sample at approximately 5 separate locations within each sample. Typical integrations times were 10–30 s for 2–3 accumulations per spectrum.

Results and discussion

SEM imaging

In Fig. 1 a SEM image of the central part of the sample is shown. Triangular shaped features with medium grey scale brightness can be identified as thin $MoS₂$ crystallites with the

Fig. 1 SEM image of the central area of the sample shown in Fig. S1.† The dark grey triangular shaped areas are the monolayer $MoS₂$ crystallites. The crystallites show a small degree of overlap. The relative fraction of the sample surface formed by the substrate, monolayer and few layer $MoS₂$ is provided in Table 1.

help of Auger microscopy and Raman spectroscopy (see Fig. S2 and S3 in the ESI†). Between the grey triangle areas lighter grey areas can be seen which is the uncovered Si wafer used as substrate. Additionally, some darker areas with overlap between the triangular crystallites can be identified and some dark areas with arbitrary shape. The latter will be identified below as contamination. The area analysis from Fig. 1 is shown in Table 1 with single $MoS₂$ sheets covering 61.4% of the surface, thicker $MoS₂$ covering 0.7%, contaminations covering 0.8% and the substrate representing 30.7% of the surface. The analysis of the coverage was done by a grey scale histogram analysis of the SEM image.

Fig. $S1\ddagger$ shows an optical image of the MoS₂. In Fig. 2 examples of key positions chosen to conduct Raman spectroscopy for evaluating the structural properties of the MoS2 are shown. The respective Raman spectra are displayed adjacent to the indicated positions. The optical image itself appears to have triangular crystalline structures which corresponds to the expected shape of $MoS₂$ crystallites.¹⁰

The first region within the triangular crystalline shape appeared to be MoS_2 with peaks at 384.8 and 404.5 cm^{-1} representing the E_{2g}^1 and A_{1g} modes, respectively. The separation of these peaks (19.4 ± 0.5 cm⁻¹) combined with the high intensity of the silicon peak at 520 cm^{-1} indicates monolayer $MoS₂$ in this region.²⁹ The peak separation of 19.7

Fig. 2 Optical images (a1–c1) and Raman spectra (a2–c2) of specific areas on the optical image. In a1 an inset with the E_{2g}^1 and A_{1g} modes are shown. In
23 an inset is shown with the congration of the E_{1g}^1 a a2 an inset is shown with the separation of the $\mathsf{E}^1_{2\mathsf{g}}$ and $\mathsf{A}_{1\mathsf{g}}$ modes.

cm⁻¹ is between those found for monolayer MoS₂ on Al₂O₃ (18 cm−¹) and Au (21 cm−¹) were for the first substrate tensile strain and for the second compressive strain has been reported.³⁷ This finding is supporting the assumption that $SiO₂$ as substrate used here results only in a weak interaction between the substrate and the $MoS₂$ monolayer. The second location, a white cloudlike region, still has $MoS₂$, however the reduced silicon peak intensity, relative to the MoS_2 peaks, indicates a higher MoS_2 concentration. The MoS₂ peaks are situated at 382.5 cm⁻¹ and 408.5 cm^{-1} and are separated by 26 cm^{-1} . This separation combined with the higher $MoS₂$ concentration than the monolayer indicates multilayer MOS_2 ^{29,38} The last region which

is a dark black spot on the optical image possesses high intensity MoS₂ peaks at 380.0 cm⁻¹ and 406.0 cm⁻¹ with no visible silicon peaks. The $MoS₂$ is thus thick enough to obstruct the detection of the silicon substrate and is classified as bulk $MoS₂$.

For better identifying the chemical nature of the crystallites AEM was applied. In the ESI† Fig. S2a shows SEM images indicating the position of the spots from which Auger spectra were taken with the latter shown in Fig. S2b.† The triangular shaped features with medium grey scale brightness can be identified as thin $MoS₂$ crystallites. Fig. S2a† shows an SEM image of a similar sample with a single triangle in position 5 identified by AES as having very low Mo and S content being

Fig. 3 XP spectra of a) C1s, b) Mo 3p, c) S 2p, d) O 1s. and e) Si 2p. The measured spectra are shown together with the fit of Shirley background and the spectral components.

linked to monolayer MoS₂. The Auger spectra clearly identify that the deposited triangular shaped material in $MoS₂$.

In the ESI† in Fig. S3 Raman spectra of one of the triangular crystallites are shown. From the Raman spectra the vast majority of the area of the triangular crystals can be identified as monolayer MoS₂ based on the separation of the $\mathrm{E}^{1}_{\mathrm{2g}}$ and A_{1g} modes.29 A small fraction of the crystallite area formed is few layer $MoS₂$.

XPS analysis

In Fig. 3 the high resolution XP spectra of the sample are shown with the binding energies of all components found listed in Table 2. In Fig. 3a the C1s spectrum is shown. The components are C1 at 285 (sp³ C–C), C2 at 286.5 \pm 0.2 eV assigned to C–O (ref. 39) or C–OH (ref. 40) or similar bonds, C3 at 288.0 \pm 0.2 eV assigned to C=O (ref. 40) and C4 at 289.8 \pm 0.2 eV assigned to C(O)OH.⁴⁰ All these carbon species are adventitious carbon. Their specific nature is not relevant for the present work. In Fig. 3b the Mo 3p doublet is shown with the $3p_{3/2}$ peak at 395.9 ± 0.2 eV which can be identified as Mo in MoS₂.⁴¹ A small peak for MoO₃ was found at 399.5 \pm 0.2 eV (ref. 41) with 16% of the overall Mo intensity. This Mo peak is not the main peak for Mo in XPS. However, the main Mo $3d_{5/2}$ peak at around 228 eV is overlapping with the S 2s peak and for this reason could not be used for the data

Table 2 Binding energies XP spectra and relative intensities averaged over all nine analysed spots

Component	Chemical species	Binding energy \pm 0.2 [eV]	Rel. intensities [%]
$C1-C1s$	$C-C$ sp ³ , adventitious	285	13.2 ± 0.3
$C2-C1s$	C-O or C-OH, 39 adventitious	286.5	3.3 ± 0.3
$C3-C1s$	$C = 0$ ⁴⁰ adventitious	288.0	0.9 ± 0.3
$C4-C1s$	$C(O)OH140$ adventitious	289.8	0.7 ± 0.3
Mo	$MoS2$ (ref. 41)	395.9	3.4 ± 0.1
Mo	$MoO3$ (ref. 41)	399.5	0.6 ± 0.1
S.	$MoS2$ (ref. 42)	162.8	7.0 ± 0.1
O ₁	$SiO2$ (ref. 43)	533.9	36.4 ± 0.4
O ₂	OH, adventitious	531.7	5.6 ± 0.4
Si1	Si (ref. 43)	99.9	8.0 ± 0.2
Si2	$SiO2$ (ref. 43)	104.5	20.9 ± 0.2

analysis. In Fig. 3c the S 2p doublet is shown with the $2p_{3/2}$ peak at 162.8 ± 0.2 eV which can be identified as Mo in MoS2. ⁴² In Fig. 3c the O 1s spectrum with one component O1 at 533.9 \pm 0.2 eV and a second small component at 531.7 \pm 0.2 eV. The first is O of $SiO₂$ (ref. 43) while the latter is probably adventitious OH. In Fig. 3d the Si 2p region with two doublets are shown. The $2p_{3/2}$ peak of one doublet is found at 99.9 \pm 0.2 eV and can be identified as Si while the second doublet is at 104.5 ± 0.2 eV which can be identified as $SiO₂$.⁴³ The ratio of Mo to S based on the relative intensities shown in Table 2 is 0.49 ± 0.02 thus corresponds to the stoichiometric ratio of the two elements.

The combined relative intensities of $MoS₂$ of 12.1% are compatible with a MoS₂ layer thickness of approximately 4 \AA at a coverage of 60%.

In Fig. 4 the relative intensities of the elements detected with XPS for all nine spots are shown. It can be seen that the coverage with $MoS₂$ is highest in the centre of the sample along the x-axis, *i.e.* at $x = 0$.

UPS analysis

In Fig. 5 the UP spectra of all nine spots analysed are shown. The components of the series of the nine spectra were analysed with SVD. SVD has been proven to be a powerful data analysis tool when the various components of a sample

Fig. 6 Spectra of the components forming the $MoS₂/Si/SiO₂$ sample: the monolayer MoS₂, few layer MoS₂ and the Si/SiO₂ substrate. For reference a spectrum of bulk $MoS₂$ is shown. In the inset the onset of the VB are shown. In the inset spectra are scaled such that they have the same intensity at their first maximum around 1 to 1.5 eV.

cannot physically be separated for the process of the analysis. SVD has been successfully applied to separate in electron spectroscopy the various components at liquid surfaces and solid surfaces, 44 clusters on surfaces 45 and interfaces in organic electronics.46

The reference spectra resulting from the SVD analysis are shown in Fig. 6 and the weighting factors for the reference spectra are shown in Fig. 7. These reference spectra represent the components forming the sample and the weighting factor the fraction of their contribution to the measured spectra. The spectrum of bulk $MoS₂$ is also shown. Two reference spectra were found representing $MoS₂$. The first reference spectrum is assigned to single monolayer of $MoS₂$. The reason for this assignment is that the spectrum shows the characteristic structure of $MoS₂$ similar to the bulk $MoS₂$ in the region 6 eV binding energy. Additionally, this reference spectrum shows a broad distribution between 6 and 10 eV which is characteristic for $SiO₂$. Thus the first reference spectrum is a combination of the spectrum from single layer

Fig. 5 UP spectra of all nine analysed spots across the sample.

Fig. 7 Weighting factors for the SVD component analysis.

 $MoS₂$ and $SiO₂$ with the later contributing only intensity at binding energies >6 eV. The part of the spectrum at <6 eV thus can be assigned exclusively to monolayer $MoS₂$. The second reference spectrum is also assigned to $MoS₂$. In contrast to the first reference spectrum it does not show the broad SiO₂ feature between 6 and 10 eV. The second reference spectrum is assigned to stacking of monolayer $MoS₂$ forming bilayers as it could be identified from Fig. 1. The valence electron cut-off is at a binding energy between monolayer and bulk $MoS₂$. This $MoS₂$ species is referred here to "few" layer. Although it is likely that this species is a double layer, we refer here to "few" because we cannot provide unambiguous evidence for a double layer species. The third reference spectrum is assigned to $SiO₂$ showing only the broad distribution between 6 and 10 eV characteristic for SiO₂. **Paper**

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In Fig. 4 the sum of the weighting factors for the first and second $MoS₂$ spectra are shown. It can be seen that the sum of the $MoS₂$ weighting factors follows closely the relative intensities of Mo and S in XPS confirming the assignment of reference spectra 1 and 2 to $MoS₂$.

The valence band (VB) cut-off for bulk $MoS₂$ is found at 0.64 ± 0.05 eV as can be seen in Fig. S3 which is similar to what was found by Timpel *et al.* for annealed MoS_2 .² Comparing the VB cut-off of both reference spectra with that of bulk $MoS₂$ it can be seen in the inset of Fig. 6 that the single layer $MoS₂$ is shifted by about 0.6 eV to higher binding energies of 1.26 eV and the few layer $MoS₂$ by about 0.25 eV to 0.89 eV; the respective VB cut-offs are also shown in Fig. S3.†

The shift in the VB cut-off is consistent with the increase in band gap found by Mak et al. who found an increase in band gap from 6 to 1 monolayer $MoS₂$ of 0.5 eV.¹ In case the conduction band (CB) cut-off does not move at the same time to lower energies, the band gap of the single and double layer $MoS₂$ has increased. Mak *et al.* found a shift in band gap of almost the same amount as found here for the change of the valence band edge for the transition from bulk to monolayer MoS2, and it could be hypothesised that the CB position does not change at the same time. However, computer calculations show a decrease in the CB position with increasing number of $MoS₂$ layers which also would contribute to a decrease of the band gap of $MoS₂$ with increasing number of layers. It should be noted that it would be needed to measure the position of the conduction band for $MoS₂$ with a variation of the number of layers, which should be possible with a technique like inverse photoemission spectroscopy.²⁸

The VB cut-off found by Eknapul et al. of $MOS₂$ with an interlayer of K is found at 1.89 eV which is larger than what is found in the present work. The reason might be the interaction of $MoS₂$ with the K interlayer. Interaction with substrates had been found by Park et al. who reported a VB cut-off for MoS_2 on SiO_2 of 1.81 eV and on Au of 1.30 eV.²⁷ Park et al. have used the same preparation as in the present work. It is unclear why the VB cut-off reported by these authors is different to our work.

Conclusion

We have determined the valence electron structure of monolayer $MoS₂$ deposited onto $SiO₂$ with UPS. Component analysis of UP spectra acquired in a spatially resolved mode separating various areas of the sample with mm resolution in combination with SEM and spatially resolved XPS have been used to separate the components in the UP spectra. The valence electron of $MoS₂$ only weakly interacting with the $SiO₂$ substrate shows a VB cut-off which is at 0.6 eV higher binding energy than bulk $MoS₂$. The double layer shows an increase in the binding energy of the cut-off of 0.25 eV.

Data availability

All data supporting this article have been included either in the main manuscript or in the ESI.†

Conflicts of interest

There is no conflict of interest to be reported.

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References

- 1 K. F. Mak, C. Lee, J. Hone, J. Shan and T. F. Heinz, Atomically Thin MoS₂: A New Direct-Gap Semiconductor, Phys. Rev. Lett., 2010, 105, 136805.
- 2 M. Timpel, G. Ligorio, A. Ghiami, L. Gavioli, E. Cavaliere, A. Chiappini, F. Rossi, L. Pasquali, F. Gärisch, E. J. W. List-Kratochvil, P. Nozar, A. Quaranta, R. Verucchi and M. V. Nardi, 2D-MoS2 goes 3D: transferring optoelectronic properties of 2D MoS2 to a large-area thin film, npj 2D Mater. Appl., 2021, 5, 64.
- 3 J. Kang, L. Zhang and S.-H. Wei, A Unified Understanding of the Thickness-Dependent Bandgap Transition in Hexagonal Two-Dimensional Semiconductors, J. Phys. Chem. Lett., 2016, 7, 597–602.
- 4 L. Zhang and A. Zunger, Evolution of Electronic Structure as a Function of Layer Thickness in Group-VIB Transition Metal Dichalcogenides: Emergence of Localization Prototypes, Nano Lett., 2015, 15, 949–957.
- 5 T. Eknapakul, P. D. C. King, M. Asakawa, P. Buaphet, R. H. He, S. K. Mo, H. Takagi, K. M. Shen, F. Baumberger, T. Sasagawa, S. Jungthawan and W. Meevasana, Electronic Structure of a Quasi-Freestanding MoS2 Monolayer, Nano Lett., 2014, 14, 1312–1316.
- 6 A. Winter, A. George, C. Neumann, Z. Tang, M. J. Mohn, J. Biskupek, N. Masurkar, A. L. M. Reddy, T. Weimann, U. Hübner, U. Kaiser and A. Turchanin, Lateral heterostructures of two-dimensional materials by electron-beam induced stitching, Carbon, 2018, 128, 106–116.
- 7 A. George, C. Neumann, D. Kaiser, R. Mupparapu, T. Lehnert, U. Hübner, Z. Tang, A. Winter, U. Kaiser, I. Staude and A. Turchanin, Controlled growth of transition metal dichalcogenide monolayers using Knudsen-type effusion cells for the precursors, JPhys Mater., 2019, 2, 016001.
- 8 G. U. Von Oertzen, S. L. Harmer and W. M. Skinner, XPS and ab initio calculation of surface states of sulfide minerals: pyrite, chalcopyrite and molybdenite, Mol. Simul., 2006, 32, 1207–1212.
- 9 W. Choi, N. Choudhary, G. H. Han, J. Park, D. Akinwande and Y. H. Lee, Recent development of two-dimensional transition metal dichalcogenides and their applications, Mater. Today, 2017, 20, 116–130.
- 10 X. Yang and B. Li, Monolayer MoS2 for nanoscale photonics, Nanophotonics, 2020, 9, 1557–1577.
- 11 F. G. Aras, A. Yilmaz, H. G. Tasdelen, A. Ozden, F. Ay, N. K. Perkgoz and A. Yeltik, A review on recent advances of chemical vapor deposition technique for monolayer transition metal dichalcogenides (MX2: Mo, W; S, Se, Te), Mater. Sci. Semicond. Process., 2022, 148, 106829.
- 12 I. Paradisanos, S. Shree, A. George, N. Leisgang, C. Robert, K. Watanabe, T. Taniguchi, R. J. Warburton, A. Turchanin, X. Marie, I. C. Gerber and B. Urbaszek, Controlling interlayer excitons in MoS2 layers grown by chemical vapor deposition, Nat. Commun., 2020, 11, 2391.
- 13 T.-X. Huang, X. Cong, S.-S. Wu, K.-Q. Lin, X. Yao, Y.-H. He, J.-B. Wu, Y.-F. Bao, S.-C. Huang, X. Wang, P.-H. Tan and B. Ren, Probing the edge-related properties of atomically thin MoS2 at nanoscale, Nat. Commun., 2019, 10, 5544.
- 14 J. Theerthagiri, R. A. Senthil, B. Senthilkumar, A. Reddy Polu, J. Madhavan and M. Ashokkumar, Recent advances in MoS2 nanostructured materials for energy and environmental applications – A review, J. Solid State Chem., 2017, 252, 43–71.
- 15 U. Yadav, H. Mishra, V. Singh, S. Kashyap, A. Srivastava, S. Yadav and P. S. Saxena, Enhanced Osteogenesis by Molybdenum Disulfide Nanosheet Reinforced Hydroxyapatite Nanocomposite Scaffolds, ACS Biomater. Sci. Eng., 2019, 5, 4511–4521.
- 16 Y. Liu and F. Gu, A wafer-scale synthesis of monolayer MoS2 and their field-effect transistors toward practical applications, Nanoscale Adv., 2021, 3, 2117–2138.
- 17 H. L. Zhu, C. J. Zhou, X. J. Huang, X. L. Wang, H. Z. Xu, Y. Lin, W. H. Yang, Y. P. Wu, W. Lin and F. Guo, Evolution of band structures in MoS2-based homo- and heterobilayers, J. Phys. D: Appl. Phys., 2016, 49, 065304.
- 18 M.-T. Wu, J.-W. Fan, K.-T. Chen, S.-T. Chang and C.-Y. Lin, Band Structure and Effective Mass in Monolayer MoS2, J. Nanosci. Nanotechnol., 2015, 15, 9151–9157.
- 19 C. Hu, C. Yuan, A. Hong, M. Guo, T. Yu and X. Luo, Work function variation of monolayer MoS2 by nitrogen-doping, Appl. Phys. Lett., 2018, 113, 041602.
- 20 W. Zhao, J. Pan, Y. Fang, X. Che, D. Wang, K. Bu and F. Huang, Metastable MoS2: Crystal Structure, Electronic Band Structure, Synthetic Approach and Intriguing Physical Properties, Chem. – Eur. J., 2018, 24, 15942–15954.
- 21 L. Szulakowska, M. Bieniek and P. Hawrylak, Electronic structure, magnetoexcitons and valley polarized electron gas in 2D crystals, Solid-State Electron., 2019, 155, 105–110.
- 22 G. Fugallo, P. Cudazzo, M. Gatti and F. Sottile, Exciton band structure of molybdenum disulfide: from monolayer to bulk, Electron. Struct., 2021, 3, 014005.
- 23 B. J. Robinson, C. E. Giusca, Y. T. Gonzalez, N. D. Kay, O. Kazakova and O. V. Kolosov, Structural, optical and electrostatic properties of single and few-layers MoS2: effect of substrate, 2D Mater., 2015, 2, 015005.
- 24 S. Aas and C. Bulutay, Geometric band properties in strained monolayer transition metal dichalcogenides using simple band structures, J. Appl. Phys., 2019, 126, 115701.
- 25 S. Ulstrup, A. G. Čabo, J. A. Miwa, J. M. Riley, S. S. Grønborg, J. C. Johannsen, C. Cacho, O. Alexander, R. T. Chapman, E. Springate, M. Bianchi, M. Dendzik, J. V. Lauritsen, P. D. C. King and P. Hofmann, Ultrafast Band Structure Control of a Two-Dimensional Heterostructure, ACS Nano, 2016, 10, 6315–6322. RSC Applied interfaces on 2024. Downloade, R. P. Bangher, R. P. Hamsher, P. R. W. S. W. S
	- 26 F. Bussolotti, J. Yang, H. Kawai, C. P. Y. Wong and K. E. J. Goh, Impact of S-Vacancies on the Charge Injection Barrier at the Electrical Contact with the MoS2 Monolayer, ACS Nano, 2021, 15, 2686–2697.
	- 27 S. Park, T. Schultz, D. Shin, N. Mutz, A. Aljarb, H. S. Kang, C.-H. Lee, L.-J. Li, X. Xu, V. Tung, E. J. W. List-Kratochvil, S. Blumstengel, P. Amsalem and N. Koch, The Schottky–Mott Rule Expanded for Two-Dimensional Semiconductors: Influence of Substrate Dielectric Screening, ACS Nano, 2021, 15, 14794–14803.
	- 28 S. Park, N. Mutz, T. Schultz, S. Blumstengel, A. Han, A. Aljarb, L.-J. Li, E. J. W. List-Kratochvil, P. Amsalem and N. Koch, Direct determination of monolayer MoS2 and WSe2 exciton binding energies on insulating and metallic substrates, 2D Mater., 2018, 5, 025003.
	- 29 C. Lee, H. Yan, L. E. Brus, T. F. Heinz, J. Hone and S. Ryu, Anomalous Lattice Vibrations of Single- and Few-Layer MoS2, ACS Nano, 2010, 4, 2695–2700.
	- 30 D. A. Shirley, High -Resolution X-Ray Photoemission Spectrum of the Valence Bands of Gold, Phys. Rev. B: Solid State, 1972, 5, 4709–4714.
	- 31 J. J. Yeh and I. Lindau, Atomic subshell photoionization cross sections and asymmetry parameters: $1 \le Z \le 103$, At. Data Nucl. Data Tables, 1985, 32, 1–155.
	- 32 M. P. Seah and W. A. Dench, Quantitative electron spectroscopy of surfaces: A standard data base for electron inelastic mean free paths in solids, Surf. Interface Anal., 1979, 1, 2–11.
- 33 H. Morgner, The quantitative characterization of liquid and solid surfaces with metastable helium atoms, in Physics of Electronic and Atomic Collisions, ed. Y. Itikawa, K. Okuno, A. H. Tanaka, A. Yagishita and M. Matsuzawa, 2000, vol. 500, pp. 687–698. **Paper** RSC Applied onted interactions of Liquid and Photochecton spectroscopy as are discussed unit when the matching to the state of Creative Commons and the common of the state of Creative Commons Articles. The State Co
	- 34 H. Morgner, The Characterization of Liquid and Solid Surfaces with Metastable Helium Atoms, in Advances In Atomic, Molecular, and Optical Physics, ed. B. Benjamin and W. Herbert, Academic Press, 2000, vol. 42, pp. 387–488.
	- 35 A. Berlich, Y. C. Liu and H. Morgner, Evaporation of Ni and Carbon Containing Species onto NiO/Ni as Case Study for Metal Support Catalysts Investigated by Metastable Induced Electron Spectroscopy (MIES), Radiat. Phys. Chem., 2005, 74, 201–209.
	- 36 J. Oberbrodhage, Determination of a solute electron energy spectrum not accessible experimentally by means of Singular Value Decomposition, J. Electron Spectrosc. Relat. Phenom., 2000, 107, 231–238.
	- 37 S. E. Panasci, E. Schilirò, G. Greco, M. Cannas, F. M. Gelardi, S. Agnello, F. Roccaforte and F. Giannazzo, Strain, Doping, and Electronic Transport of Large Area Monolayer MoS2 Exfoliated on Gold and Transferred to an Insulating Substrate, ACS Appl. Mater. Interfaces, 2021, 13, 31248–31259.
	- 38 S. Mignuzzi, A. J. Pollard, N. Bonini, B. Brennan, I. S. Gilmore, M. A. Pimenta, D. Richards and D. Roy, Effect of disorder on Raman scattering of single-layer $MoS₂, Phys. Rev.$ B: Condens. Matter Mater. Phys., 2015, 91, 195411.
	- 39 S. Rella, E. Mazzotta, A. Caroli, M. De Luca, C. Bucci and C. Malitesta, Investigation of polydopamine coatings by X-ray

Photoelectron Spectroscopy as an effective tool for improving biomolecule conjugation, Appl. Surf. Sci., 2018, 447, 31–39.

- 40 D. Yang, A. Velamakanni, G. Bozoklu, S. Park, M. Stoller, R. D. Piner, S. Stankovich, I. Jung, D. A. Field, C. A. Ventrice and R. S. Ruoff, Chemical analysis of graphene oxide films after heat and chemical treatments by X-ray photoelectron and Micro-Raman spectroscopy, Carbon, 2009, 47, 145–152.
- 41 T. A. Patterson, J. C. Carver, D. E. Leyden and D. M. Hercules, A surface study of cobalt-molybdena-alumina catalysts using x-ray photoelectron spectroscopy, J. Phys. Chem., 1976, 80, 1700–1708.
- 42 N. H. Turner and A. M. Single, Determination of peak positions and areas from wide-scan XPS spectra, Surf. Interface Anal., 1990, 15, 215–222.
- 43 M. H. Kibel and P. W. Leech, X-ray Photoelectron Spectroscopy Study of Optical Waveguide Glasses, Surf. Interface Anal., 1996, 24, 605–610.
- 44 B. Heinz and H. Morgner, Surface characterization by means of quantitative evaluation of MIES data, J. Electron Spectrosc. Relat. Phenom., 1998, 96, 83–95.
- 45 G. Krishnan, H. S. Al Qahtani, J. Li, Y. Yin, N. Eom, V. B. Golovko, G. F. Metha and G. G. Andersson, Investigation of Ligand-Stabilized Gold Clusters on Defect-Rich Titania, J. Phys. Chem. C, 2017, 121, 28007–28016.
- 46 A. R. Alghamdi, J. M. Bjuggren, X. Pan, M. R. Andersson and G. G. Andersson, Dipole Formation at Active Materials/ P(NDI3N-T-Br) Interface in Organic-Based Photovoltaic, Macromol. Mater. Eng., 2022, 307, 2200303.